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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/530,634	04/07/2005	Jurgen Holz	10808/231	7531
48581 7590 01/18/2007 BRINKS HOFER GILSON & LIONE INFINEON PO BOX 10395 CHICAGO, IL 60610			EXAMINER CRUZ, LESLIE PILAR	
			ART UNIT	PAPER NUMBER
			2826	
SHORTENED STATUTORY PERIOD OF RESPONSE		MAIL DATE	DELIVERY MODE	
3 MONTHS		01/18/2007	PAPER	

**Please find below and/or attached an Office communication concerning this application or proceeding.**

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

<b>Office Action Summary</b>	<b>Application No.</b> 10/530,634	<b>Applicant(s)</b> HOLZ ET AL.	
	<b>Examiner</b> Leslie P. Cruz	<b>Art Unit</b> 2826	

**-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --**

**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.


- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☒ Responsive to communication(s) filed on 22 November 2006.
- 2a) ☐ This action is **FINAL**.                      2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 1,2 and 4-9 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 1,2 and 4-9 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

  
**Minhloan Tran**  
**Primary Examiner**  
**Art Unit 2826**

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 07 April 2005 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

**Priority under 35 U.S.C. § 119**

- 12) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☒ All    b) ☐ Some \*    c) ☐ None of:
1. ☒ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).
- \* See the attached detailed Office action for a list of the certified copies not received.

**Attachment(s)**

- |   |   |
|---|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)   | 4) <input type="checkbox"/> Interview Summary (PTO-413)<br>Paper No(s)/Mail Date. _____ |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)  | 5) <input type="checkbox"/> Notice of Informal Patent Application                       |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08)<br>Paper No(s)/Mail Date <u>04/07/2005</u> | 6) <input type="checkbox"/> Other: _____  |

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## **DETAILED ACTION**

### ***Election/Restrictions***

Applicant's election of Group I, drawn to a field-effect transistor in the reply filed on 11/22/2006 is acknowledged. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)). Accordingly, pending in the Office Action are claims 1-2 & 4-9.

### ***Priority***

Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

### ***Information Disclosure Statement***

The Information Disclosure Statement(s) filed on 04/07/2005 has been considered.

### ***Oath/Declaration***

The oath or declaration filed on 04/07/2005 is acceptable.

### ***Drawings***

The drawings filed on 04/07/2005 are acceptable.

***Preliminary Amendment***

The preliminary amendment filed on 04/07/2005 has been entered.

***Claim Rejections - 35 USC § 102***

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 2, 4, 6 and 9 are rejected under 35 U.S.C. 102(b) as being anticipated by Chung (US 5,943,575).

With respect to claim 1, Chung (e.g. Figs. 2 and 3k) discloses a field-effect transistor with local source-drain insulation, having a semiconductor substrate [21]; a source depression and a drain depression [either side of 23], which are formed in a manner spaced apart from one another in the semiconductor substrate; a depression insulation layer [24], which is formed at least in a bottom region of the source depression and of the drain depression; an electrically conductive filling layer [36,37], which is formed for realizing source and drain regions and for filling the source and drain depressions at a surface of the depression insulation layer; a gate dielectric [30], which is formed at a substrate surface between the source and drain depressions; and a gate layer [31], which is formed at a surface of the gate dielectric, a widening [34] with a predetermined depth for realizing defined channel connection regions.

With respect to claim 2, Chung discloses the field-effect transistor as claimed in claim 1. Chung (e.g. Figs. 2 and 3k) further discloses the depression insulation layer has a depression

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sidewall insulation layer, which is formed in a sidewall region of the source and drain depressions but does not touch the gate dielectric.

With respect to claim 4, Chung discloses the field-effect transistor as claimed in claim 1. Chung (e.g. Figs. 2 and 3k) further discloses the electrically conductive filling layer has a seed layer for improving a deposition in the source and drain depressions [column 4 lines 44-47].

With respect to claim 6, Chung discloses the field-effect transistor as claimed in claim 1. Chung (e.g. Figs. 2 and 3k) further discloses the field-effect transistor is bounded by shallow trench isolations [28].

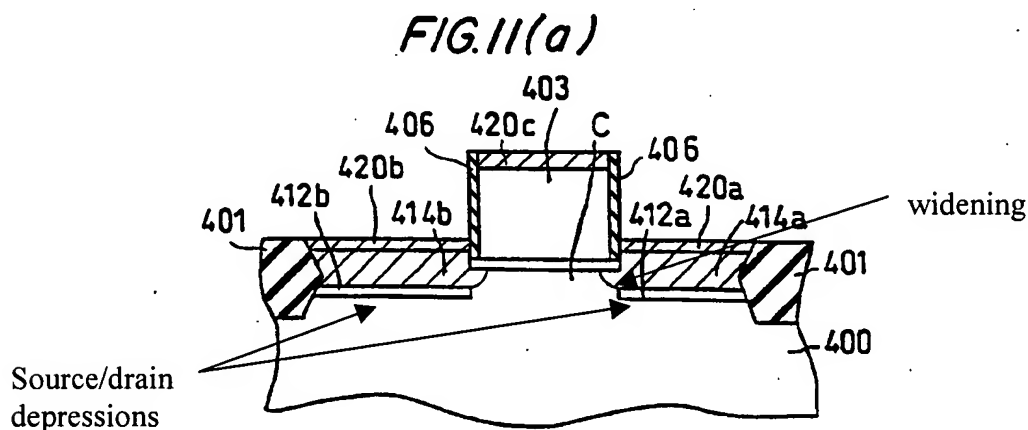
With respect to claim 9, Chung discloses the field-effect transistor as claimed in claim 1. Chung (e.g. Figs. 2 and 3k) further discloses the depression sidewall insulation layer extends into a region below the gate dielectric.

Claims 1 and 5 are rejected under 35 U.S.C. 102(b) as being anticipated by Tsuchiaki (US 2001/0025998 A1).

With respect to claim 1, Tsuchiaki (e.g. Figs. 11(a)-12(c)) discloses a field-effect transistor with local source-drain insulation, having a semiconductor substrate [400]; a source depression and a drain depression [see figure below], which are formed in a manner spaced apart from one another in the semiconductor substrate; a depression insulation layer [412a, 412b], which is formed at least in a bottom region of the source depression and of the drain depression; an electrically conductive filling layer [414a, 414b], which is formed for realizing source and drain regions and for filling the source and drain depressions at a surface of the depression insulation layer; a gate dielectric [402], which is formed at a substrate surface between the source and drain depressions; and a gate layer [403], which is formed at a surface of the gate dielectric,

wherein the source and drain depressions have, in an upper region, a widening [see figure below] with a predetermined depth for realizing defined channel connection regions.

With respect to claim 5, Tsuchiaki discloses the field-effect transistor as claimed in claim 1. Tsuchiaki (e.g. Figs. 11(a)-12(c)) further discloses a gate insulation layer [406] is formed at sidewalls of the gate layer.



### ***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

Claims 7 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsuchiaki.

With respect to claims 7 and 8, Tsuchiaki discloses the field-effect transistor as claimed in claim 1. Tsuchiaki does not disclose that the field-effect transistor has lateral structures  $< 100$

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nm or that the source and drain depressions have a depth of approximately 50 nm to 300 nm. However, it would have been obvious to one of ordinary skill in the art at the time the invention was made for the field-effect transistor of Tsuchiaki to have lateral structures < 100 nm or the source and drain depressions have a depth of approximately 50 nm to 300 nm in order to miniaturize the device while suppressing the resistance. The specific claimed relative dimensions of the lateral structures or the source and drain depressions, absent any criticality, are only considered to be the “optimum” dimensions that a person having ordinary skill in the art would have been able to determine using routine experimentation based, among other things, on the desired adhesive strength, manufacturing costs, etc. (see Boesch, 205 USPQ 215 (CCPA 1980)), and since neither non-obvious nor unexpected results, *i.e.*, results which are different in kind and not in degree from the results of the prior art, will be obtained.

Accordingly, since the applicants have not established the criticality (see next paragraph below) of the stated relative thicknesses, it would have been obvious to one of ordinary skill in the art to use these values in the device of Tsuchiaki.

The specification contains no disclosure of either the critical nature of the claimed dimensions or any unexpected results arising therefrom. Where patentability is said to be based upon particular chosen dimensions or upon another variable recited in a claim, the applicant must show that the chosen dimensions are critical. *In re Woodruff*, 919 F.2d 1575, 1578, 16 USPQ2d 1934, 1936 (Fed. Cir. 1990).

Therefore, claims 7 and 8 are not patentably distinguishable over the Tsuchiaki reference.

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***Telephone/Fax Information***

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Leslie P. Cruz whose telephone number is (571) 272-8599. The examiner can normally be reached on Monday-Friday 9:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisors, Wael Fahmy or Bob Pascal can be reached on (571) 272-1705 and (571) 272-1769, respectively. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.



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